

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants : Gabriele Barlocchi et al.
Application No. : 10/667,113
Confirmation No. : 2816
Filed : September 18, 2003
For : METHOD FOR FORMING HORIZONTAL BURIED CHANNELS
OR CAVITIES IN WAFERS OF MONOCRYSTALLINE
SEMICONDUCTOR MATERIAL

Examiner : Fazli Erdem
Art Unit : 2826
Docket No. : 854063.552D1
Date : May 12, 2008

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

FEE DEFICIENCY AUTHORIZATION FORM

Commissioner for Patents:

Applicants hereby authorize the Director to charge any deficiencies in fees due by way of the enclosed papers only under 37 CFR 1.16 and 1.17 to Deposit Account No. 19-1090.

Respectfully submitted,
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